

#4 Pre
AMDI
RG A
2-24-99

35.C12395 CIP

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
YOSHIHIKO FUKUMOTO)
Application No.: C-I-P of)
08/979,957 and :
08/714,437)
Filed: Herewith)
For: METHOD FOR)
FABRICATING)
SEMICONDUCTOR DEVICE) October 28, 1999

Assistant Commissioner for Patents
Washington, D.C. 20231

PRELIMINARY AMENDMENT

Contemporaneous with the filing of the subject
application, kindly amend the application as follows:

IN THE SPECIFICATION:

Page 1, line 2, insert

"Express Mail" mailing label number EL 293309455US

Date of Deposit OCTOBER 28, 1999
I hereby certify that this paper or fee is being deposited
with the United States Postal Service "Express Mail
Post Office to Addressee" service under 37 CFR 1.10
on the date indicated above and is addressed to:
Assistant Commissioner of Patents, Washington, D.C.
20231

GREGORY FRIPP
(Type or printed name of person mailing paper or fee)

GREGORY FRIPP
(Signature of person mailing paper or fee)